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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/888,302	06/21/2001	Jeff E. Blackwood	5201-24200 01-006	9532	
75	90 03/31/2003				
Gary B. Goates			EXAMINER		
LSI Logic Corporation 1551 McCarthy Blvd.			NGUYEN, VINH P		
MS D-106					
Milpitas, CA 95035			ART UNIT	PAPER NUMBER	
			2829		
			DATE MAILED: 03/31/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

E = 1	•	Application No.	Applicant(s)		
		09/888,302	•	JW	
	Office Action Summary			BLACKWOOD, JEFF E.	
	,	Examin r	Art Unit		
	Th MAILING DATE of this communication app	VINH P NGUYEN	2829		
Period fo	or Reply	rears on an Coversin et v	viui the correspond ince ad	aress	
I HE I - Exter after - If the - If NO - Failu - Any r	ORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.1 SIX (6) MONTHS from the mailing date of this communication. It period for reply specified above is less than thirty (30) days, a reply operiod for reply is specified above, the maximum statutory period or re to reply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a y within the statutory minimum of the will apply and will expire SIX (6) MO	reply be timely filed irty (30) days will be considered timely NTHS from the mailing date of this co	<i>ı.</i> ımmunication.	
1) 🖂	Responsive to communication(s) filed on 21 c	lune 2001			
2a) □		is action is non-final.			
3)					
•	Since this application is in condition for allowated closed in accordance with the practice under a con of Claims	Ex parte Quayle, 1935 C	nters, prosecution as to the D. 11, 453 O.G. 213.	∍ merits is	
4) 🖾	Claim(s) 1-20 is/are pending in the application				
•	4a) Of the above claim(s) is/are withdrav	vn from consideration.			
	Claim(s) is/are allowed.				
6)⊠	Claim(s) <u>1-20</u> is/are rejected.				
7)	Claim(s) is/are objected to.				
8) 🗌	Claim(s) are subject to restriction and/or	election requirement.			
	on Papers	4			
9)∐ T	he specification is objected to by the Examiner		,		
10)∐ T	he drawing(s) filed on is/are: a)∏ accep	ted or b) objected to by t	he Examiner.		
	Applicant may not request that any objection to the	drawing(s) be held in abeya	ance. See 37 CFR 1.85(a).		
11) 🗌 T	he proposed drawing correction filed on	is: a) ☐ approved b) ☐ d	isapproved by the Examiner	r.	
	If approved, corrected drawings are required in repl	y to this Office action.			
12) 🔲 T	he oath or declaration is objected to by the Exa	miner.			
Priority ur	nder 35 U.S.C. §§ 119 and 120				
13) 🗌 🛚 A	Acknowledgment is made of a claim for foreign	priority under 35 U.S.C.	§ 119(a)-(d) or (f).		
	All b)☐ Some * c)☐ None of:				
1	. Certified copies of the priority documents	have been received.			
2	2. Certified copies of the priority documents		pplication No.		
	B. Copies of the certified copies of the priorit application from the International Bure se the attached detailed Office action for a list o	y documents have been	received in this National S	lage	
	knowledgment is made of a claim for domestic			polication	
a) [The translation of the foreign language proveknowledgment is made of a claim for domestic	isional application has be	en received	ppiioudolij.	
Attachment(s			00 .== aa.o. 1 <u>=</u> 1.		
2) 🔲 Notice (of References Cited (PTO-892) of Draftsperson's Patent Drawing Review (PTO-948) tion Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of Ir	ummary (PTO-413) Paper No(s). Iformal Patent Application (PTO-	· 152)	
Patent and Trade O-326 (Rev.	04.04)	on Summary	Part of D	aner No. 2	

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1. Claims 5-6 are rejected under 35 U.S.C. 112, first paragraph, as containing subject matter which was not described in the specification in such a way as to enable one skilled in the art to which it pertains, or with which it is most nearly connected, to make and/or use the invention.

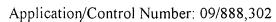
It appears that the specification does not disclose the limitation of "wherein the holder is adapted to receive an outer perimetr of the wafer frontside surface by applying vacuum pressure thereto" as recited in claim 5 and the limitation of "wherein the holder is adapted to receive an outer perimetr of the wafer frontside surface by tabs arranged intermittently around the outer perimeter" as recited in claim 6.

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 3. Claims 1-4,7-20 rejected under 35 U.S.C. 102(b) as being anticipated by Ishii et al (Pat # 5,493,236).

As to claims 1-4 and 7-12 and 15-17,20, Ishii et al disclose a test analysis apparatus as shown in figure 1 having at least one electrically conductive probe needled (45) formed on a probe card (44), an optical scan mechanism ((30,31,32,33,34,35), a holder and a mechanism (21) adapted to receive a wafer (20) and to move the wafer relative to the probe needle. It



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appears that the front side of the wafer is contacted by the probes (45) and the backside of the wafer is adapted to receive radiation from the optical scan mechanism. Furthermore, it also appears that the photoemission from the wafer is also detected by the optical scan mechanism so that the defects are detected. As to claim 13, it appears that a test device (103) is connected to a bonding pad through the probe needles (45) and this test device is activated for applying/receiving electrical energy to/from the bonding pads. As to claim 14, it appears that the wafer is retained at an outer perimeter and this wafer is moved relative to the probe needles (45). As to claims 16-17, it appears that the probe needles (45) has that capability.

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 5. Claims 5-6 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ishii et al (pat #5,493,236) in view of Brown et al (Pat #5,959,461).

Ishii et al disclose a test analysis apparatus as mentioned in paragraph 3. Ishii et al do not teach a holder having tabs arranged intermittently around the outer perimeter or a vacuum pressure applied at an outer perimeter of the wafer. As to claim 5, Brown et al disclose a holder

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(34) is adapted to receive an outer perimeter of the wafer (50) frontside surface by applying

vacuum pressure thereto (see column 4, lines 42-53). As to claim 6, Brown et al also disclose tas

(54) arranged intermittently around the outer perimeter. It would have been obvious for one of

ordinary skill in the art to provide the teaching of using vacuum pressure and tabs as taught by

Brown et al to the device of Isshii et al so that the wafer is secured tightly to the holder during

the test.

6. Any inquiry concerning this communication or earlier communications from the examiner

should be directed to VINH P. NGUYEN whose telephone number is (703) 305-4914.

Any inquiry of a general nature or relating to the status of this application or proceeding

should be directed to the Group receptionist whose telephone number is (703) 305-4900.

VINH P. NGUÝEN

PRIMARY EXAMINER

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03/19/200

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